Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination
10/004,885	ABURAKAWA ET AL.
Examiner	Art Unit
Khai M. Nguyen	2687

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Class	Subclass	Date	Examiner
455	561 550.1 560 73	9/9/2005	KN
379	56.2 56.1	9/9/2005	KN
379	429	9/9/2005	KN
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
see	attached		KN
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	SEARCH NOT (INCLUDING SEARCH:
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